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Theoretical and experimental study of ScAlN/Sapphire structure based SAW sensor

Institut Jean Lamour UMR 7198
Université de Lorraine - CNRS
54506 Vandœuvre-lès-Nancy, France

F. Bartoli, T. Aubert
LMOPS EA 4423
CentraleSupélec - Université de Lorraine
57070 Metz, France

S. Hage-Ali, P. Boulet, H. M’Jahed and O. Elmazria,
Institut Jean Lamour UMR 7198
Université de Lorraine - CNRS
54506 Vandœuvre-lès-Nancy, France

Abstract — Several SAW devices based on Sc_{0.1}Al_{0.9}/Sapphire bilayer structures were fabricated using various wavelengths and film thicknesses. The acoustic velocity, electromechanical coupling coefficient and temperature coefficient of frequency (TCF) of each device was then measured and the results were compared with calculations using several sets of elastic, piezoelectric and dielectric constants available in the literature. We have shown that the accuracy of available constants is not enough to permit a reliable optimization and design of SAW devices for signal processing and sensors applications.

Keywords—Temperature sensor, SAW, ScAlN

I. INTRODUCTION

Thanks to its high acoustic phase velocity, low motional resistance, high thermal conductivity, and CMOS-compatibility [1,2], AlN thin films have attracted attention as piezoelectric material for RF-MEMS including bulk and surface acoustic wave devices. Moreover, AlN is chemically inert and shows a high temperature stability. Indeed it is an intrinsically-poled, non-ferroelectric material (no Curie point) which has been reported to retain its piezoelectric properties at temperatures above 1000°C [3]. However, the low electromechanical coupling coefficient (K^2) and piezoelectric constant (d_{33}) of AlN thin compared to PZT and ZnO thin films, limits its wide applications in sensors, wide band filters, and MEMS including for energy harvesting.

Recently, several studies have shown that the addition of Sc to form Sc_{x}Al_{1-x}N strongly increases the measured piezoelectric coefficients of ScAlN alloys, until reaching a phase transition to the non-polar rocksalt-type structure [1,2] (x=0.43). It was reported that an enhancement of 400% of d_{33} is obtained for Sc_{0.43}Al_{0.57}N alloys compared to pure AlN [4]. Moreover, the ScAlN has all the advantages of the AlN mentioned below. Because of its strong electromechanical coupling and improved piezoelectricity, ScAlN allows to widen the field of applications and especially that of sensors. Note also that the expected energy harvesting factor of merit (FOM = \frac{d_{33}^{2}}{\rho v_{s}}) for Sc_{0.43}Al_{0.57}N (60GPa) is larger than those of PZT (24GPa) or ZnO (10.8GPa) [5].

The aim of this work is to develop a wireless, batteryless and packageless acoustic wave sensor based on the three layers structure AlN/ScAlN/Sapphire. In order to develop fully operational sensors and optimize their design according to the targeted performance, the full and accurate physical constants of the materials considered are a prerequisite. If these constants are now well established for Sapphire and AlN, it is not the case for ScAlN. Several sets of constants could be found in literature [7-11] and these constants are of course depending on the concentration of scandium in the film. These constants, determined by different experimental methods or by calculation, show a strong scatter, making the choice of the accurate set difficult. Consequently, and in order to determine the most suitable set of constants, we first studied the bilayer structure ScAlN/Sapphire and compared experimental results with calculated ones. The selected set is then used to optimize the whole set constants AlN/ScAlN/Sapphire structure.

II. MODELING DETAILS AND METHOD

Phase velocity of ScAlN/Sapphire structures have been determined using the recently reported Legendre and Laguerre polynomial approach of wave propagation in layered magneto-electro-elastic structures by which is a flexible and computationally efficient alternative to the classical solution of transcendental equations [12]. For S_{11} coefficient calculation, a numerical model in Comsol Multiphysics using general partial derivative equations interface. A half period of an infinite IDT with periodic boundary conditions in the propagation direction is used. Dispersion curves of acoustic velocity were calculated versus ScAlN film thickness, and for various Sc concentration in the film.

Like AlN, ScAlN is part of the family of hexagonal piezoelectric crystals (class 6mm) and can be defined by 10 independent material constants as follows:

- Elastic stiffness: C_{11}, C_{12}, C_{13}, C_{33}, C_{44}, with C_{66} = \frac{C_{11}-C_{12}}{2}
- Piezoelectric constants: e_{15}, e_{31}, e_{33}
- Dielectric constants: \varepsilon_{11}, \varepsilon_{33}, \varepsilon_{33}

To optimize the considered structure and thus the design of acoustic wave devices, the full and accurate material constant
sets are required. Table 1 summarizes the main data collected in published works concerning the ScAlN. It has been demonstrated by calculation [10] and experimentally [9] that the elastic constants $C_{ij}$ vary linearly with the concentration of Scandium. In order to obtain a complete set of constants for lower concentrations, we have determined these constants by extrapolation considering those of the pure AlN ($x = 0\%$) and the available ones (generally $x = 43\%$).

### TABLE I. PHYSICAL CONSTANTS OF CONSIDERED MATERIAL

<table>
<thead>
<tr>
<th>Material</th>
<th>Elastic stiffness (GPa)</th>
<th>Piezoelectric constants (C/m$^2$)</th>
<th>Dielectric constants</th>
<th>Density (kgm$^{-3}$)</th>
<th>Ref</th>
</tr>
</thead>
<tbody>
<tr>
<td>AIN</td>
<td></td>
<td>$e_{11}$, $e_{12}$, $e_{33}$</td>
<td>$e_{11e}$, $e_{12e}$</td>
<td>8, 9.5</td>
<td>6</td>
</tr>
<tr>
<td>Sc$_{43%}$AlN</td>
<td></td>
<td>$C_{11}$, $C_{12}$, $C_{13}$, $C_{33}$, $C_{44}$, $C_{66}$</td>
<td></td>
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<tr>
<td></td>
<td>345, 125, 120</td>
<td>-0.48, -0.58, 1.55</td>
<td>282.4, 136.5, 125.2, 169.6, 98.1, 98.1</td>
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<tr>
<td></td>
<td>101.4, 128.4, 267.4, 39.6, 66.6</td>
<td>1.03, -0.886, 0.863</td>
<td>293, 146, 130, 184, 100, 74.7</td>
<td>30.5, 30.28, 3760</td>
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</tr>
<tr>
<td></td>
<td>211, 51.5, 53.9</td>
<td>-1.31, -1.58, 4.42</td>
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<td></td>
<td>169, 61.2, 58.8</td>
<td>-0.294, -0.516, 2.72</td>
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<td></td>
<td>125.2, 169.6, 98.1</td>
<td>-0.317, -0.722, 2.73</td>
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<tr>
<td></td>
<td>108.6</td>
<td>-1.31, -1.58, 4.42</td>
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<td></td>
<td>108.6</td>
<td>30.5, 30.28</td>
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<td>98.1</td>
<td>3760</td>
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<td>98.1</td>
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</table>

III. EXPERIMENTAL

A. ScAlN deposition

Scandium Aluminum Nitride thin films were deposited by reactive magnetron sputtering. 10% scandium and 18% scandium thin films have been made with single composite Sc/Al targets, respectively composed of 12.5% and 25% of Scandium. The films compositions have been measured by Energy Dispersive X-Ray Spectroscopy (EDXS). Structural properties such as microstructure and nanostructure have been determined by θ-2θ, rocking-curve and pole figures X-Rays Diffraction (XRD) measurements and by Transmission Electron Microscopy (TEM) measurements. The Sc$_{10\%}$Al$_{90\%}$N and Sc$_{18\%}$Al$_{82\%}$N thin films shows strong (002) orientation, with high texturing which guarantees good piezoelectric properties which in principle enables to obtain good piezoelectric properties.

B. SAW devices fabrication

Several SAW devices based on ScAlN/Sapphire bilayer structures were fabricated using photolithography and chemical etching process. SAW devices consist in asynchronous resonator. Aluminum Interdigital transducer (IDT) and reflectors were fabricated by conventional contact ultraviolet (UV) photolithography. Resonators consist in 100 IDT pairs and 200 reflectors on each side. Two spatial periods ($\lambda = 6.5$ and $13\mu$m) and three ScAlN thicknesses ($1.6$, $2.23$ and $2.76$ $\mu$m) were considered. Thus, six values of relative thickness ($h_{\text{ScAlN}} = h/\lambda$) are obtained, leading to plot dispersion curves of velocity, $K^2$ and temperature coefficient of frequency (TCF).

IV. RESULTS AND DISCUSSION

As an example, figure 1 shows the wide range frequency response of a SAW resonator fabricated with ($\lambda = 6.5$ $\mu$m and $h_{\text{ScAlN}} = 2.76$ $\mu$m). We can observe the Rayleigh wave at 729 MHz and its 2$\text{nd}$ and 3$\text{rd}$ mode at 1025MHz and 1566MHz. The larger coupling is obtained for the 3$\text{rd}$ mode ($K^2 = 1.7\%$) while 0.77% and 0.49% were obtained respectively for modes 1 and 2. We note that for lower relative thicknesses of ScAlN, only the mode 1 of Rayleigh wave is generated. In the following part our study will be focused only on this mode. The phase velocities ($v$) were determined from the resonance frequency ($f_r$) ($v = \lambda/f_r$). The experimental values of $K^2$ were determined using resonance ($f_r$) and antiresonance ($f_a$) frequencies determined from admittance $Y$ plot and using formula $K^2 = 1 - (f_r/f_a)^2$. All devices were characterized versus temperature leading to determination of TCF values.

Figure 2 shows the dispersion curves of the phase velocity for a scandium concentration of 43%. As reference curve, dispersion curves of pure AlN were also plotted in the same graphs. As expected, the calculated values are strongly dependent on the considered set of constants. To determine the most accurate set, we plot in the same graph the experimental value of velocity considered set of constants. To determine the most accurate set, the experimental data are closer to those calculated for 43% of scandium with Zhang set [10]. These differences could be explained by cracks at the surface due to the high temperature deposition of the ScAlN thin film, which could decrease the SAW velocity. Further investigations are made for more informations. If the data published by Konno remains the closes to the experimental ones, they are nevertheless not suitable for making a reliable optimization.
TCF values were also determined for various devices made with Sc$_{0.1}$Al$_{0.9}$N. These values are depending on both relative film thickness and scandium concentration. For characterized devices the TCF is ranging from -110 ppm/$^\circ$C to -40 ppm/$^\circ$C. For instance, Figure 4 shows a TCF of -67 ppm/$^\circ$C, for temperatures between 20$^\circ$C and 500$^\circ$C. Therefore, the Sc$_{0.1}$Al$_{0.9}$N shows a good sensitivity of the temperature, and it is able to operate up to 500$^\circ$C. Since the IDT were made with aluminum, the robustness of the film to higher temperatures has not been tested yet. Moreover, the advantage of such structure is that the TCF and thus the sensitivity of the temperature sensor, could be adjusted to match application requirements by controlling the film thickness and/or the Sc to Al ratio.

V. CONCLUSION

Highly textured Scandium Aluminum Nitride thin films were deposited by reactive magnetron sputtering on sapphire substrates. The film quality was demonstrated by XRD and TEM measurements and by the performances of the fabricated SAW resonators. The comparison of the dispersion curves of velocity calculated and determined experimentally, shows a strong divergence thus suggesting the inaccuracy of the physical constants available in the literature for the ScAlN. The unavailability of elastic constants thermal properties does not make it possible to determine the TCF of the ScAlN/Sapphire structure by calculation.

REFERENCES